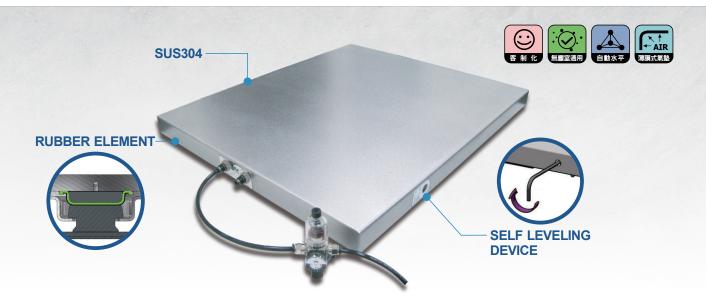




■ 8 MODEL x58(H)mm

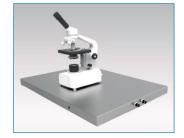


MORE SLIM

The slim design provides an elegant appearance and is suitable for all equipments.

APPLICATIONS

- SURFACE ROUGHNESS MEASURING SYSTEM CONTOUR MEASURING SYSTEM
- **MICROSCOPE**
- SEMICONDUCTOR MEASURING SYSTEM SCANNING WHITE LIGHT INTERFEROMETER
- SLIM DESIGN Platform height only 58mm, easy to operate.
- SUS304 TOP Apply orbital finish to the top as anti-scratch treatment.



MORE CONVENIENT

Self leveling design with 3 height control valves.



- SELF LEVELING DEVICE (PATENT NO. M490951)
- CUSTOMIZED DESIGN High damping design can be customized according to the requirement.

MORE SUPERIOR

1mm thickness rubber element provides high performance.

